

Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/523,313	STEIGER, ECKARD
	Examiner John A. Tweel, Jr.	Art Unit 2612

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
340	438	1/30/2008	JAT
701	29	1/30/2008	JAT